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Examiner Initials*	Cite	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Pages, Columns, Line	
	No.1	, Number-Kind Code <sup>2 (f Incom)</sup>		Applicant of Cited Document	Relevant Passages or Relevant Figures Appear
M.L.	1	<sup>US-</sup> 5,790,124	08-04-1998	Fischer, et al.	
M.L.		us- 6,086,380	07-11-2000	Chu, et al.	
M.C		<sup>US-</sup> 6,231,347	05-15-2001	Tsai	
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M.L.	V	<sup>US-</sup> 60/369,279	04-02-2002	Sharma et al.	
M.L.	<u>-</u>	us- 60/394,324	07-08-2002	Sharma et al.	
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FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Foreign Patent Document Publication Oate MM-DD-YYYY  Country Code <sup>3</sup> "Number * "Kind Code <sup>5</sup> (if known)		Name of Patentee or Applicant of Cited Document	Peges, Columns, Lines, Where Relevant Passages		
				Or Relevant Figuree Appear	To		
ML		EP-0,782,338	02-07-1997				
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PTO/S8/088 (02-03)

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		OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
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M.L.		S. Lee, et al., Proc. of International Conference on Virtual Systems and MultiMedia, 2001	
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Examiner Signature	MATTHEW LUU	Date Considered	2/11/05	

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